

# Fast amplifier for SiPM characterization in a wide temperature range for the next RICH experiments

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# SiPM characterization amplifier

- The next generation of RICH (Ring Imaging Cherenkov) detectors may use **SiPMs (Silicon PhotoMultipliers)** as photodetectors.
- SiPMs need to be **characterized with good timing resolution (tens of picoseconds) at different temperatures** to study the effects of radiation damage as a function of operating temperature (between  $\sim 80$  K and  $\sim 300$  K).
- Fast transimpedance signal amplifier for **SiPM characterization**.
- **Low power consumption, adequate for cryogenic operation**: 175 mW @  $\sim 300$  K and 100 mW at @  $\sim 80$  K per amplifier.
- **Very low noise** ( $< 1 \frac{\text{nV}}{\sqrt{\text{Hz}}}$ ) and **very fast response** ( $< 500$  ps) result in **very low jitter (high time resolution)**.



Electronics' jitter

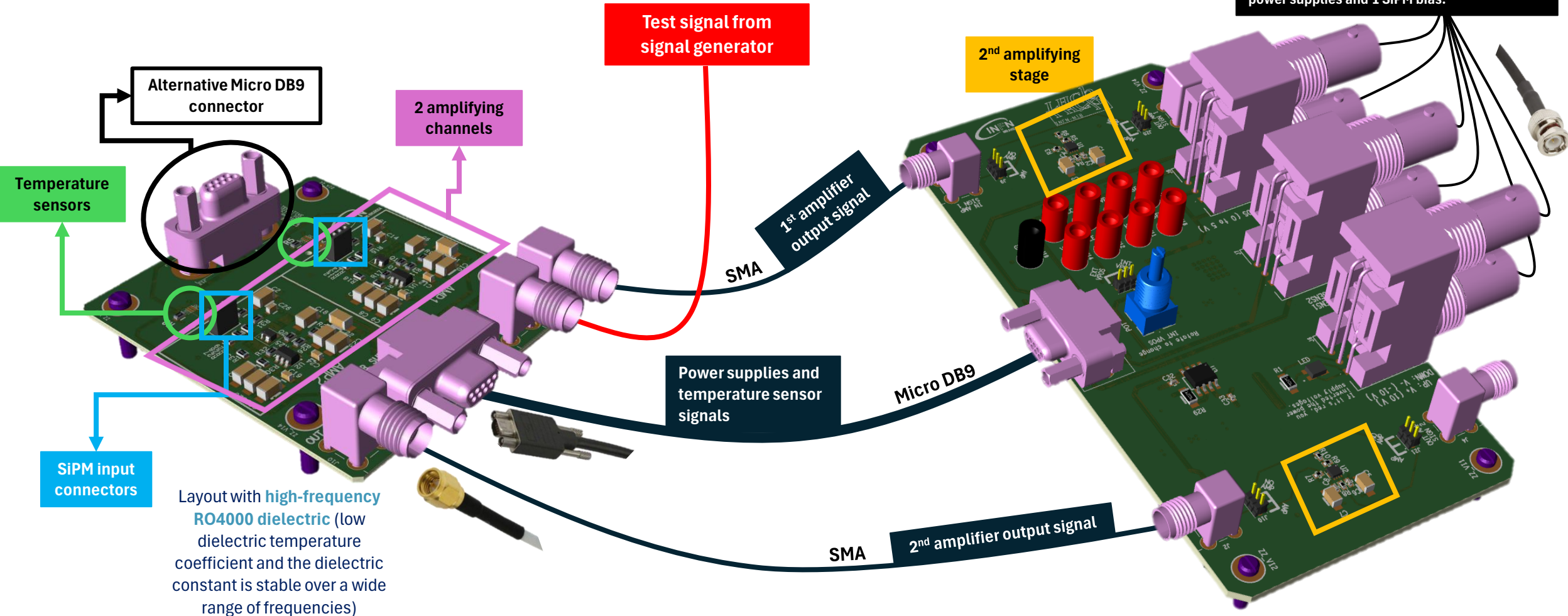
$$\sigma_t = \frac{C}{Q_S} \sqrt{\frac{e_{\text{amp}}^2}{f_{\text{BW}}}}$$

- $\overline{e_{\text{amp}}^2}$ : input referred amplifier noise.
- $f_{\text{BW}}$ : amplifier bandwidth frequency.
- $Q_S$ : charge produced by the source.
- C: constant.

# The complete setup

- **Cold electronics (left):** SiPM amplification (x2 channels), test signal and temperature sensor. It can work between 80 K and 300 K.
- **Ambient temperature electronics (right):** 2<sup>nd</sup> amplifying stage and power supply control. It operates at 300 K.

- 1) To oscilloscope (x2 SMA & x2 BNC):
  - Amplifier output signals (x2 SMA).
  - Temperature sensor signals (x2 BNC).
- 2) To power supplies (x4 BNC): 3 amplifiers' power supplies and 1 SiPM bias.



Layout with high-frequency RO4000 dielectric (low dielectric temperature coefficient and the dielectric constant is stable over a wide range of frequencies)

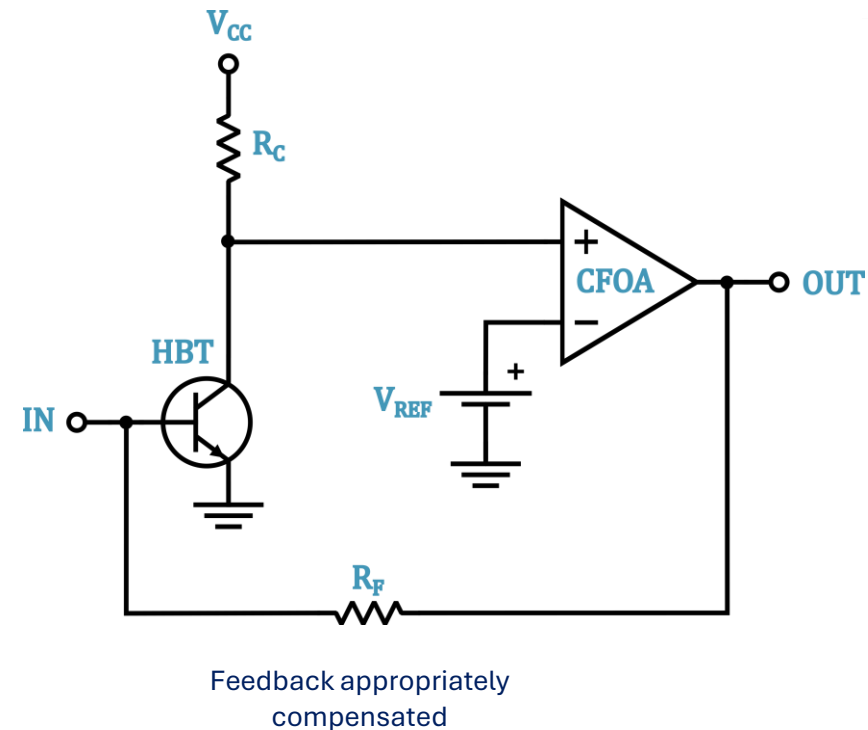
# Simplified amplifier schematic

## Amplifier summary (cold electronics):

- Low noise **HBT** (Heterojunction Bipolar Transistor).
- The transistor current is provided through resistor  $R_C$ .
- **Fast CFOA** (Current Feedback Operational Amplifier) that can also operate at cryogenic temperatures.
- The feedback path is closed by a feedback resistor  $R_F$ .
- Output signal:
  - Gain:  $7500 \Omega = 77.5 \text{ dB } (\Omega/\Omega)$ .
  - Bandwidth:  $\sim 1 \text{ GHz @ } 300 \text{ K}$  and  $\sim 700 \text{ MHz @ } 80 \text{ K}$ .
  - Input referred noise:  $\sim 0.9 \frac{\text{nV}}{\sqrt{\text{Hz}}}$  @ 300 K and  $\sim 0.5 \frac{\text{nV}}{\sqrt{\text{Hz}}}$  @ 80 K.



- The output signal is sent to the **ambient temperature board**.
- This output signal can be amplified by the **2<sup>nd</sup> stage amplifier**:
  - Large bandwidth: 3 GHz.
  - Gain: 3.5 V/V using a 50  $\Omega$  transmission line terminated on both ends.
- This second amplifying stage **can be bypassed**.

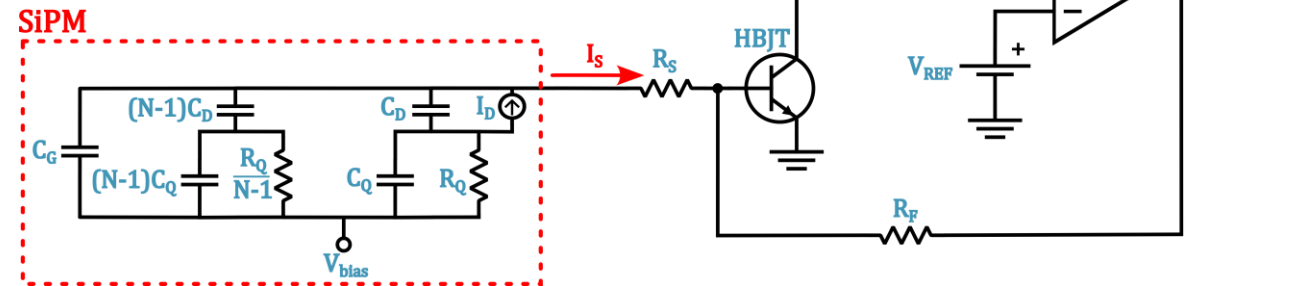
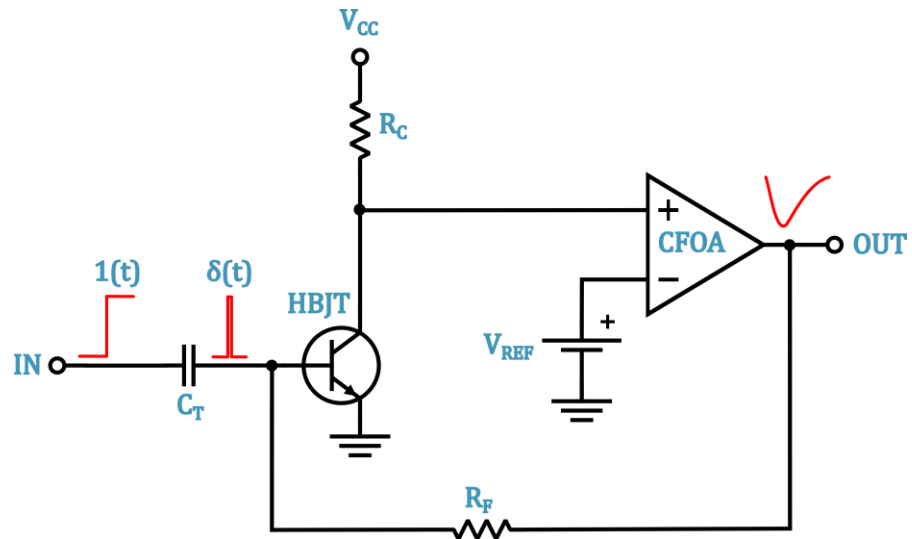


# Performed tests

- Tests were performed with both the test and SiPM signals.

Test signal

SiPM signal



- $V_{OV} = V_{bias} - V_{br}$ : overdrive voltage, with  $V_{br}$  being the breakdown voltage.
- $C_D$ : single diode capacitance
- $I_D$ : avalanche current
- $C_D$ : diode capacitance
- $R_Q$ : quenching resistor
- $C_Q$ : quenching parasitic capacitance
- $C_G$ : grid parasitic capacitance
- $\tau_s = (C_D + C_Q)(R_Q + R_S)$

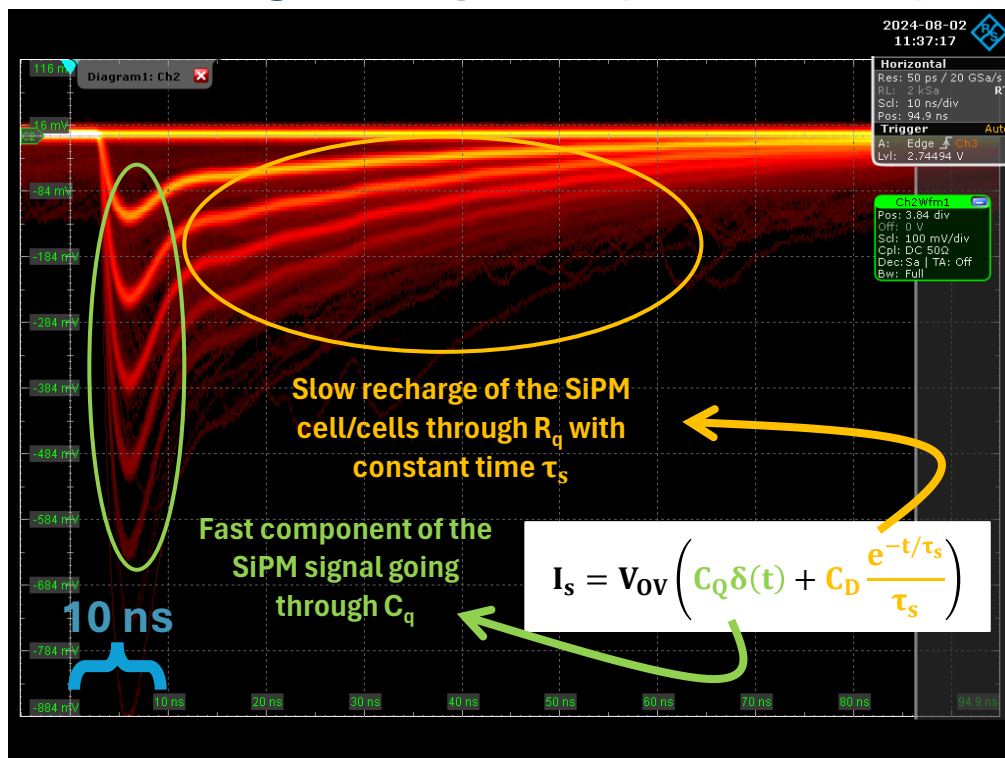
- Step voltage charges a test capacitor  $C_T$ .
- Dirac delta-like current signal** into the amplifier to test the amplifier capabilities.
- Measurement of rise time, fall time and amplifier's contribution to the jitter.

- SiPM signal** fed into the amplifier through  $R_S = 50 \Omega$ .
- Measurement of parameters such as rise time, fall time and jitter due to both the SiPM and amplifier (amplifier's jitter and fall time are negligible).

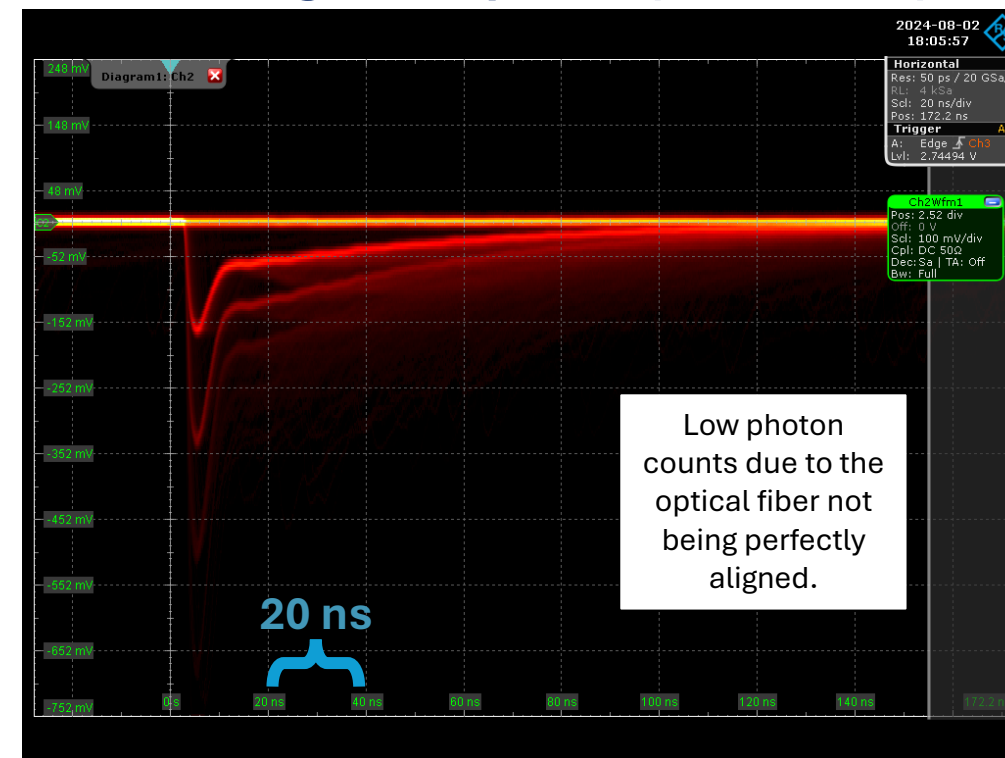
# Amplifier response to a SiPM signal

- The **SiPM signal** can be written as  $I_s = V_{OV} \left( C_Q \delta(t) + C_D \frac{e^{-t/\tau_s}}{\tau_s} \right)$ .
- The amplifier was tested with a **1.3mm x 1.3mm Hamamatus SiPM (S13360-1350)**.
- The photons were produced by a **405 nm laser** controlled by the **Hamamatsu PLP-10 pulser** (70 ps FWHM pulses).
- Here are shown the oscilloscope screenshots of **photon counting measurements** with the SiPMs operated at  $3 V_{OV}$ .

## SiPM signal response (300 K, 3 Vov)



## SiPM signal response (80 K, 3 Vov)

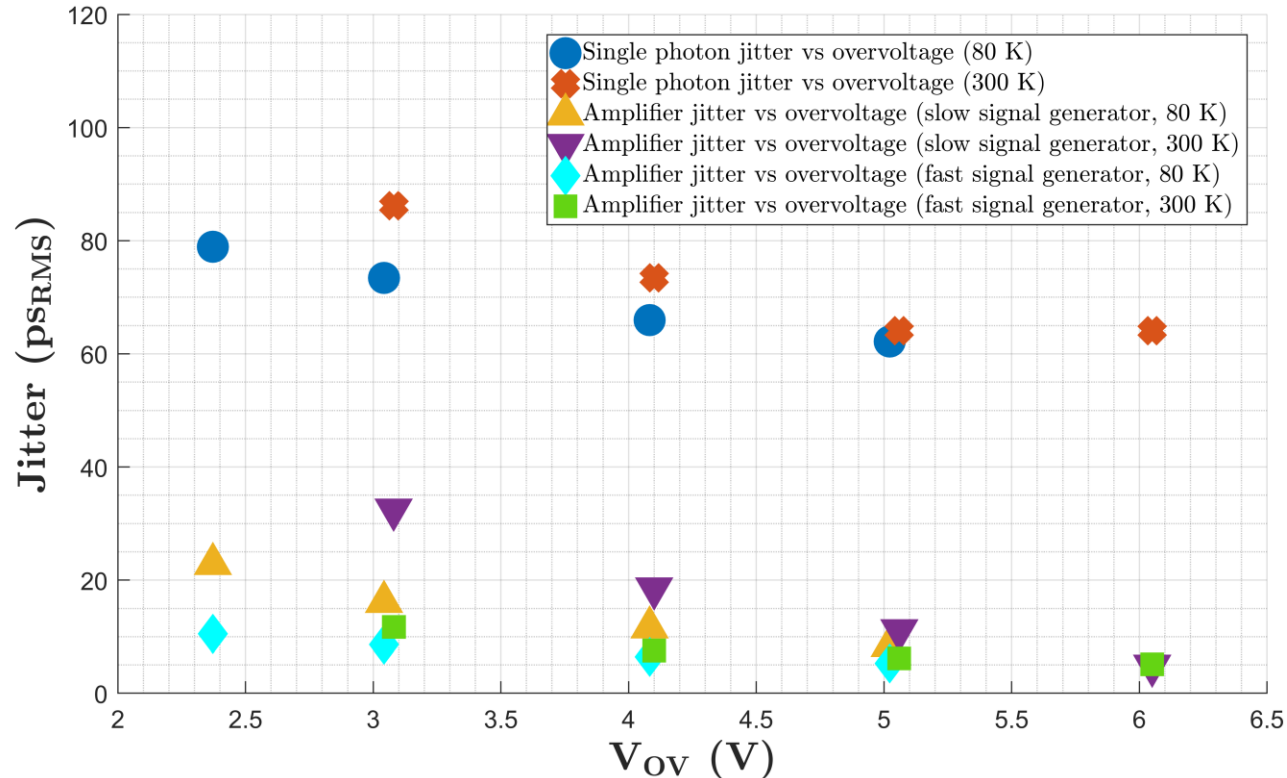




# Jitter measurements summary

- Measurement of the amplifier (amplifier jitter) and SiPM+amplifier (single photon jitter) jitter contributions.
- Jitter contributions from the **signal generator**, **oscilloscope** and **laser pulses** have been subtracted.
- This plot summarizes all the results for the SiPM and amplifier jitter measurements

Jitter measurements



- The **amplifier jitter** was measured with:
  1. **Fast signal generator** to simulate an ideal input signal with negligible rise time.
  2. **Slow signal generator** simulates the real rise time of a SiPM input signal  $\rightarrow$  slower signal means higher jitter.
- Amplifier jitter measured with an **input step voltage amplitude** equal to the amplitude of single-photon SiPM signals at different  $V_{OV}$   $\rightarrow$  more amplitude (higher  $V_{OV}$ ) means less jitter.

**Thanks for the attention!**